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(54) Title: TRANSPARENT CONDUCTIVE OXIDES

(57) Abstract: A method of deposition of a transparent conductive film from a metallic target is presented. A method of forming a transparent conductive oxide film according to embodiments of the present invention include depositing the transparent conductive oxide film in a pulsed DC reactive ion process with substrate bias, and controlling at least one process parameter to affect at least one characteristic of the conductive oxide film. The resulting transparent oxide film, which in some embodiments can be an indium-tin oxide film, can exhibit a wide range of material properties depending on variations in process parameters. For example, varying the process parameters can result in a film with a wide range of resistive properties and surface smoothness of the film.

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C. DOCUMENTS CONSIDERED TO BE RELEVANT		
Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	KELLY P J ET AL: "A novel technique for the deposition of aluminium-doped zinc oxide films" PREPARATION AND CHARACTERIZATION, ELSEVIER SEQUOIA, NL, vol. 426, no. 1-2, 24 February 2003 (2003-02-24), pages 111-116, XP004414901 ISSN: 0040-6090 page 112, right-hand column - page 115, paragraph 1 ----- -/--	1,2,4,5, 8-12,14, 18-20, 22,23
<input checked="" type="checkbox"/>	Further documents are listed in the continuation of box C.	
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° Special categories of cited documents :		
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C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
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